Electronic Acknowledgement Receipt					
EFS ID:	1941381				
Application Number:	10511883				
International Application Number:					
Confirmation Number:	4213				
Title of Invention:	Apparatus and method for depositing thin film on wafer using remote plasma				
First Named Inventor/Applicant Name:	Young Hoon Park				
Customer Number:	23413				
Filer:	James J. Merrick/Shenita Carroll				
Filer Authorized By:	James J. Merrick				
Attorney Docket Number:	YPL-0108				
Receipt Date:	05-JUL-2007				
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Time Stamp:	14:30:59				
Application Type:	U.S. National Stage under 35 USC 371				
Payment information:					

## Payment information

Submitted with Payment	no
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# File Listing:

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Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Amendment - After Non-Final Rejection	Response_to_Office_Action_ YPL-0108.pdf	1077753	no	12
Warnings:					

Information:							
2	Miscellaneous Incoming Letter	Marked_up_Specification_Y PL-0108.pdf	2158877	no	15		
Warnings:							
Information:							
3	Miscellaneous Incoming Letter	Clean_Specification_YPL-01 08.pdf	2108737	no	15		
Warnings:							
Information	:						
		Total Files Size (in bytes):	5345367				

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card. as described in MPEP 503.

#### New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

#### National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

### New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.